

FORM PTO-1449

**INFORMATION DISCLOSURE CITATION**

#2

Atty Docket  
0140/00272

Serial No.  
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Applicant  
Arpan P. Mahorowala

Filing Date 7/12/01  
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Group Art Unit  
1754  
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**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
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**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub-Class	Translation
	AL						Yes No
	AM						Yes No
	AN						Yes No
	AO						Yes No
	AP						Yes No

**OTHER** (Including Author, Title, Date, Pertinent Pages, etc.)

hly	AR		Pattern Collapse in the Top Surface Imaging Process After Dry Development; Shigeyasu Mori, et al.; J. Vac. Sci. Technol. B 16(6); pp. 3744-3747 (Nov/Dec 1998)
	AS		
	AT		

Examiner *Michael Hansen*

Date Considered 5/28/03

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 600. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant(s).